

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ismail EMESH et al. Group Art Unit: 3723
Serial No.: 10/729,119 Examiner: Shakeri, Hadi
Filed: December 4, 2003 Confirmation No.: 3177
For: LUBRICANT FOR WAFER POLISHING USING A FIXED
ABRASIVE PAD
Attorney Docket No.: 004.0122

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is responsive to the final Office Action mailed on January 22, 2007. Please amend the above-identified application as set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.